

SEP 23 2004

Appl. No. 10/607,869

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/607,869  
Filing Date ..... June 27, 2003  
Inventor..... Zhongze Wang  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2812  
Examiner ..... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-2343  
Customer No. .... 021567  
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

**RESPONSE TO JUNE 25, 2004 OFFICE ACTION**

To: Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**AMENDMENTS****Introductory Comments**

In reply to the Office Action of June 25, 2004, applicant amends and remarks as follows.